Preliminary Amendment U.S.S.N. 10/621,079 Page 15 of 15

#### REMARKS

This preliminary amendment corrects an unintentional and inadvertent printing error that occurred when the original version of the application was printed for filing.

Support for the amendment to the specification comes from the priority Provisional Application – incorporated by reference. Accordingly no new matter has been added to this application by virtue of this preliminary amendment.

Correction of the specification is respectfully requested.

### FEE AUTHORIZATION

Please charge any fees due in connection with this filing to our Deposit Account – No. 19-0733.

#### CERTIFICATE OF FACSIMILE TRANSMISSION

The undersigned hereby certifies that this correspondence was submitted by facsimile in the USPTO on the date shown on Page 1.

Respectfully submitted,

Erzest V. Linek (29,822)

Attorney for Applicant

Document No. 98565

#### METHOD AND APPARATUS FOR REAL TIME MONITORING OF ELECTROPLATING BATH PERFORMANCE AND BARLY FAULT DETECTION

#### PRIORITY CLAIM

[0001] This application claims priority from commonly owned, opposting U.S. Provisional Application Serial No. 60/397,133, filed 19 Jul. 2002, the disclosure of which is hereby incorporated berein by reference.

#### FIELD OF THE INVENTION

[6002] The present invantion sclases generally to any plating solution and methods for monitoring its performance. More specifically, the present invention relates to plating beths and methods for mentioring their plating functionally based on chemometric analysis of voltammetric data obtained for these baths. More particularly, the method of the present invention relates to the application of numerous chemometric techniques to describe quantitatively plating bath functionally in order to maintain proper dively plating bath functionally in order to maintain proper performance of the baths. [Taxt missing or Hinglishe when filled] shock, depend on concentrations of constituents. Should the constituents fail pushed of required concentration ranges, however, the bath may fail to satisfactorily perform its plating function. It is thursdoor important that deliberately added constituent concentrations are regularly and accurately monitored. Current techniques for plating bath components analysis, recently reviewed by Wikid et al. [1], do not employ reliable calibration methods employing multivariate data explayer capable of demoting online.

[0003] Unfortunately, most organic additives undergo degradation meetions, which lead not only to the depiction of their concentration but also to the introduction of degradation products in the plating hath. These degradation products accumulate and some of them impede the performance of plating bath. The degradation of polyonyethylene-based sufficients (like the carrier in a copper plating bath) was discussed by Donbrow [2]. Peasable degradation processes of beightener and carrier for copper plating bath were suggested by Dietz [3]. He concluded that the dosing logic for carrier based on the charge that flows through the plating solution conton to correlated with carrier depiction. Dietz listeal several contaminants that interfere with the brightener function: foreign metal contaminants, westing agains from upowers cleaning operations, pre-plate microetchauts, and materials leaching out of photoresists. Another possible foreign contamination are remains of hydrogen peroxide used for plating tank is aching and/or carbon treatment cycles.

[6004] Nose of the current techniques for plating bath components analysis, reviewed by Whiel et al. [1] deal with bath contamination at all, assuming performance of plating bath being equal to the freshly prepared plating solution.

[6005] The only existing method of checking the plating bath performance based on the visual symmetries of the deposit is Hull cell test that causes be performed with lo-tank electrochemical sensors. Two different sets of equipment must must therefore be maintained in order to perform constituent analysis and contamination detection, as those two factors determine proper performance of the plating bath. No integrated measurement system is available which is expalle of measuring constituent concentrations and of distanting bath contamination. Additionally, the major draw-

back of the Hull cell test is its capability to detect bath contamination only after the plating performance is already impeded. There is no existing technique for early detection of plating bath contamination that would enable execution of proper counter measurements before the plating performance is affected by the greatence of contaminants.

[0006] Burly detection of bath malfunctioning is crucial to avoid losses especially in the electronic industry where the cost of silicon walter plated with defects may be corpetimes measured in hundreds of thousands dollers. Recently implemented to the semiconductor manufacturing copper damascene plating process is especially sensitive to any unex-pected parturbation. This includes not only any deviation from a very tight process specification, but also an extremely difficult to control accumulation of organic additive breakdown products. A complex structure on water surface (consisting of sub-micrometer size (entures—vies and trenches) has to be filled-in with copper with no defects, during the deposition step. The ability of the copper plating bath to fill-in this kind of small feature depends very much on the ratio of the organic additives—suppressors and socclerators. The mechanism of curvature subacced accelerator coverage was proposed to explained superfilling properties of the electrolyte [4-7]. A pronounced bystaresis is observed in the copper voltammogram taken for the solution with such superfilling properties. But it is well known that the breakdown products of the accelerator can display either accelcration and/or suppression effect, while presistown products of suppressors will be showing suppression offers of various strength. Thus the performance of a plating bath can be impeded severely because of such additional, and not controlled by any means, effects. Plating problems can be observed in solution with accumulated breakdown products, even when the deliberately added components of plating bath, measured by any analytical method, are within the specification range. Thus, even the accurate analysis of all of the target components may be not enough for the good performance of a plating bath.

[9007] The hamful effect of accumulated degradation products will be very dependent on the process specification and the size of features to be plated. Certain level of braidown products can be fully acceptable for plating 0.25-micron features, while the same amount can produce defective parts when plating 0.13-micron or smaller gaps. In order to keep good both performance, a renovation process called blood-and-feed was introduced into the plating practice for acmicouchactor manufacturing. Every certain amount of time, a portion of the plating solution is removed from the tank and replaced with a freshly-prepared, contamination-free plating bath. This process is deas without any analytical control. Thus, very often this procedure is performed unnecessarily, causing a total waste of still good (and also expensive) plating solution.

[0008] There is no simple and straightforward analytical method to evaluate the effect of degradation products of organic additives. So it is apparent that there presently is a need for a fast and inexpensive method capable of monitoring bath performance and/or early detection of plating problems.

#### SUMMARY OF THE INVENTION

[0009] Dischased is a process to produce a predictive data set which can be used to predict the property of a plating solution, said process comprising:



# PROVISIONAL PATENT APPLICATION Docket No. 004522/00010

# METHOD AND APPARATUS FOR REAL TIME MONITORING OF ELECTROPLATING BATH PERFORMANCE AND EARLY FAULT DETECTION

#### FIELD OF THE INVENTION

The present invention relates generally to any plating solution and methods for monitoring its performance. More specifically, the present invention relates to plating bath and methods for monitoring its plating functionality based on chemometric analysis of voltammetric data obtained for these baths. More particularly, the method of the present invention relates to application of numerous chemometric techniques to describe quantitatively plating bath functionality in order to maintain its proper performance.

## BACKGROUND OF THE INVENTION

### Sources of Improper Performance of Plating Bath

A typical plating bath solution comprises a combination of several different chemical constituents. The specific constituents vary depending upon the type of plating bath. The concentration levels of constituents are important determinants of the quality of the resultant plating deposit. The characteristics of the plating deposit, including tensile strength, ductility, solderability, uniformity, brighteness and resistance to thermal